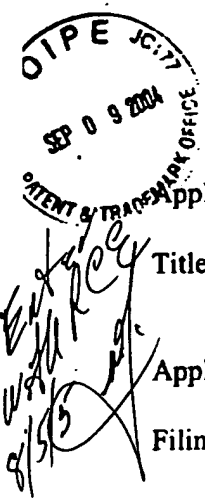


**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

  
Applicant: Robert Nakayama *et al.*  
Title: SENSOR FABRICATING  
METHOD  
Appl. No.: 09/847,885  
Filing Date: 05/02/2001  
Examiner: Brian K. Talbot  
Art Unit: 1762

**AMENDMENT AND REPLY UNDER 37 CFR 1.116**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

This communication is responsive to the Final Office Action dated April 20, 2004, concerning the above-referenced patent application.

Applicants have enclosed with this amendment a Petition for Extension of Time to make this response timely.

**Amendments to the Specification** begin on page 2 of this document.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this document.

**Remarks/Arguments** begin on page 6 of this document.

Please amend the application as follows:

09/10/2004 SDEK0031 00000039 09847885

11 FC:1252

420.00 UP